

# Notice of Allowability

Application No.

10/523,169

Examiner

G. Nagesh Rao

Applicant(s)

KURIMURA ET AL.

Art Unit

1722

## -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. ☐ This communication is responsive to \_\_\_\_\_.
2. ☒ The allowed claim(s) is/are 1-13.
3. ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a) ☒ All    b) ☐ Some\*    c) ☐ None    of the:
  1. ☒ Certified copies of the priority documents have been received.
  2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

\* Certified copies not received: \_\_\_\_\_.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  
**THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.**

4. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
5. ☐ CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.
  - (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached
    - 1) ☐ hereto or 2) ☐ to Paper No./Mail Date \_\_\_\_\_.
  - (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date \_\_\_\_\_.Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
6. ☐ DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

### Attachment(s)

- |  |   |
|--|---|
| 1. <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)  | 5. <input type="checkbox"/> Notice of Informal Patent Application                     |
| 2. <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)                               | 6. <input type="checkbox"/> Interview Summary (PTO-413),<br>Paper No./Mail Date _____ |
| 3. <input checked="" type="checkbox"/> Information Disclosure Statements (PTO/SB/08),<br>Paper No./Mail Date _____ | 7. <input type="checkbox"/> Examiner's Amendment/Comment                              |
| 4. <input type="checkbox"/> Examiner's Comment Regarding Requirement for Deposit<br>of Biological Material         | 8. <input checked="" type="checkbox"/> Examiner's Statement of Reasons for Allowance  |
|  | 9. <input type="checkbox"/> Other _____   |

***Reasons For Allowance***

1) The following is an examiner's statement of reasons for allowance: Upon extensive review of applicant's claims, co-pending applications, and review of the PCT JPO Intl. Search report, it is the examiner's position that the case has met the criterion for first action allowance. Examiner was unable to locate prior art that read on any of the following limitations below:

"A quasi-phase matched quartz crystal which is characterized in that surface step working is performed on the surface of one side so that this surface has protruding parts consisting of a periodic or arbitrary pattern, and the protruding parts consisting of this periodic or arbitrary pattern are composed of aggregates of protruding parts of an even finer pattern."

"A method for manufacturing a quasi-phase matched quartz crystal comprising a step in which a quartz crystal on which surface step working has been performed so that this quartz crystal has protruding parts consisting of a periodic or arbitrary pattern is subjected to the application of pressure by pressing a planar substrate at a specified temperature, thus inverting the crystal axes in the portions corresponding to the protruding parts, this quasi-phase matched quartz crystal manufacturing method being characterized in that the protruding parts consisting of a periodic or arbitrary pattern are composed of aggregates of protruding parts of

an even finer pattern.” Nor

“A method for manufacturing a quasi-phase matched quartz crystal comprising a step in which a quartz crystal substrate whose surface has been polished to a flat surface is subjected to the application of pressure by being pressed at a specified temperature by a surface that has been subjected to surface step working so that this surface has protruding parts consisting of a periodic or arbitrary pattern, thus inverting the crystal axes of the portions of the quartz crystal that correspond to the protruding parts, this quasi-phase matched quartz crystal manufacturing method being characterized in that the protruding parts consisting of the periodic or arbitrary pattern are composed of aggregates of protruding parts of an even finer pattern.”

The closest prior art examiner located were of similar nature to applicant’s Kurimura and Harada’s co-pending applications, but no Obvious or Statutory Double Patenting issues arose.

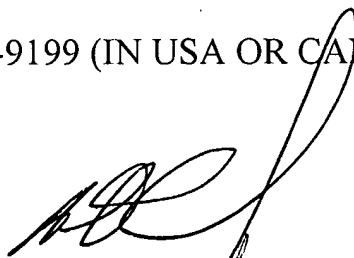
Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled “Comments on Statement of Reasons for Allowance.”

Any inquiry concerning this communication or earlier communications from the examiner should be directed to G. Nagesh Rao whose telephone number is (571) 272-2946. The examiner can normally be reached on 9AM-5PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Yogendra Gupta can be reached on (571)272-1316. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

GNR



Robert Kunen  
Primary Examiner  
TC 1700